



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 18, 2026

IGI Report Number

LG799604270

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

Measurements

14.43 X 9.72 X 6.65 MM

GRADING RESULTS

Carat Weight

8.04 CARATS

Color Grade

F

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

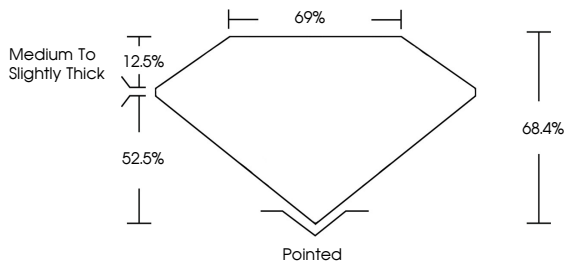
Inscription(s)

 LG799604270

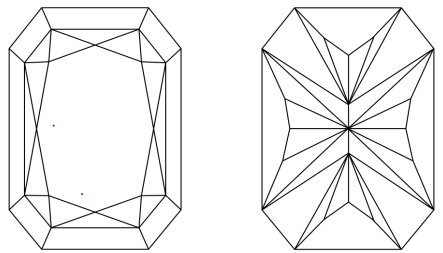
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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14.43 X 9.72 X 6.65 MM

Carat Weight

8.04 CARATS

Color Grade

F

Clarity Grade

VVS 2

Table

12.5%

Depth

52.5%

Girdle

68.4%

Medium to Slightly Thick

Culet

Pointed

Polish

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Symmetry

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Fluorescence

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